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## **ABSTRACT**

A mini-environment pod device for a micro-device manufacturing apparatus includes a cassette being able to hold a plurality of wafers, a pod providing an inner space to store the cassette, wherein the pod includes an electromagnetic shield, and a lid which fits into an opening of the pod. The lid provides an isolated environment in the inner space. When the mini-environment pod is installed on the manufacturing apparatus, the electromagnetic shield is in a conductive relationship with a shielded chamber of the manufacturing apparatus.

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